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PATENT APPLICATION Docket No.: 3194.1026-006

## **巻D STATES PATENT AND TRADEMARK OFFICE**

Applicants:

Jeffrey J. Spiegelman, Daniel Alvarez, Jr., Russell J. Holmes and Allan Tram

Application No.: 10/523,371

Group: 1792

371(c) Date:

June 21, 2005

Examiner: Bibi Sharidan Carrillo

Confirmation No.: 3702

For:

METHOD FOR THE REMOVAL OF AIRBORNE MOLECULAR

CONTAMINANTS USING OXYGEN AND/OR WATER GAS MIXTURES

CERTIFICATE OF MAILING OR TRANSMISSION

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450, or is being faesimile transmitted to the United States Patent and Trademark Office on:

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Typed or printed name of person signing certificate

## REPLY AND ELECTION OF SPECIES

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Responsive to the requirement for an election of species for searching purposes, Applicants hereby elect "silicon substrate or wafer" as the species. Claims readable on the elected species are Claims 1, 3-5, 8-9, 11, 14-15, 38-49.

Applicants reserve the right to file a continuing application or take such other appropriate action as deemed necessary to protect the non-elected inventions. Applicants do not hereby abandon or waive any rights in the non-elected inventions.

## **Supplemental Information Disclosure Statement**

A Supplemental Information Disclosure Statement (IDS) is being filed concurrently herewith. Entry of the SIDS is respectfully requested.

Respectfully submitted,

HAMILTON, BROOK, SMITH & REYNOLDS, P.C.

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